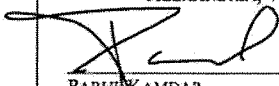


IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In Re Application of:	§	
JOAN BENDER ET AL.	§	Group Art Unit: 2835
	§	
Serial No: 10/767,027	§	Examiner: ANATOLY VORTMAN
	§	
Filed: JANUARY 29, 2004	§	
	§	
For: LOW RESISTANCE POLYMER	§	Attorney Docket: 13682.105201
MATRIX FUSE APPARATUS AND	§	(CET-026431 CIP1)
METHOD	§	
	§	

**Mail Stop AF**  
**Commissioner for Patents**  
**P.O. Box 1450**  
**Alexandria, VA 22313-1450**

<p align="center"><b>CERTIFICATE OF FILING ELECTRONICALLY VIA EFS</b> <b>MPEP 503</b></p> <p>I HEREBY CERTIFY THAT I HAVE A REASONABLE BASIS FOR BELIEF THAT THIS CORRESPONDENCE IS BEING SUBMITTED TO THE UNITED STATES PATENT AND TRADEMARK OFFICE VIA EFS (ELECTRONICALLY) ON THE DATE INDICATED BELOW, AND IS ADDRESSED TO:</p> <p align="center">MAIL STOP AF COMMISSIONER FOR PATENTS PO BOX 1450 ALEXANDRIA, VA 22313-1450</p> <p align="center"> PARUL KAMDAR</p> <p align="right">MARCH 14, 2008</p>
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**RESPONSE TO FINAL OFFICE ACTION MAILED JANUARY 14, 2008**

Dear Sir:

In Response to the Final Office Action mailed January 14, 2008, Applicants herein provide:

- **Amendments to the Claims** reflected in the listing of claims which begins on page 2 of this paper; and
- **Remarks/Arguments** which begin on page 6 of this paper.